



IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

Application Serial No.09/881,408
Confirmation No.....8492
Filing Date June 13, 2001
Inventor..... Kie Y. Ahn, et al
Assignee..... Micron Technology, Inc.
Group Art Unit.....2814
Examiner T. Le
Attorney's Docket No.MI22-1534
Customer No.021567
Title: A Dielectric Layer Forming Method and Devices Formed Therewith

PRELIMINARY AMENDMENT TO ACCOMPANY AN RCE FILING

To: Box RCE
 Commissioner for Patents
 PO Box 1450
 Art Unit 2814
 Alexandria, VA 22313-1450

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AMENDMENTS

No amendments.